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THE UNITED STATES PATENT AND TRADEMARK OFFICE

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Applicant:

John T. Moore et al.

Group Art Unit:

2811

Serial No.:

09/496,794

Examiner:

Douglas Owens

Filed:

February 2, 2000-

Atty. Dkt. No.:

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97-0608

For:

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Semiconductor Devices

Defined factor Bevices

Commissioner for Patents Washington DC 20231

REPLY TO PAPER NO. 14

Sir:

In response to the office action mailed July 31, 2002, please amend the application as

follows:

IN THE CLAIMS

Please cancel claims \$1-34.

REMARKS

The pending claims 26-30 were rejected under § 103 over the patent to Fazan that is assigned to Micron Technology, Inc. as is the present application. Moreover, the Fazan patent issued less than a year before the filing date of this application. Therefore under 35 U.S.C. § 103(c), the Fazan patent cannot be used to fashion a § 103 rejection of the present application. See M.P.E.P. § 2146.

Date of Deposit: A Liquis 21 2002

I hereby certify under 37/CFR 1.8(a) that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage on the date indicated above and is addressed to the Commissioner for Patents, Washington DC 20231.

Cynthia L. Hayden